

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masatake NAKANO

Group Art Unit: 2812

Application No.: 10/500,381

Examiner: S. ISAAC

Filed: June 29, 2004

Docket No.: 120164

For: METHOD OF PRODUCING SOI WAFER AND MAIL STOP RCE  
SOI WAFER

**LARGE ENTITY REQUEST FOR**  
**CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

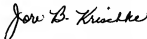
In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the Amendment After Final Rejection filed June 13, 2006.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

The fees associated with this filing under are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,



William P. Berridge  
Registration No. 30,024

Jori B. Krischke  
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WPB:JBK/rav

Date: July 27, 2006

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<p><b>DEPOSIT ACCOUNT USE</b> <b>AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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